



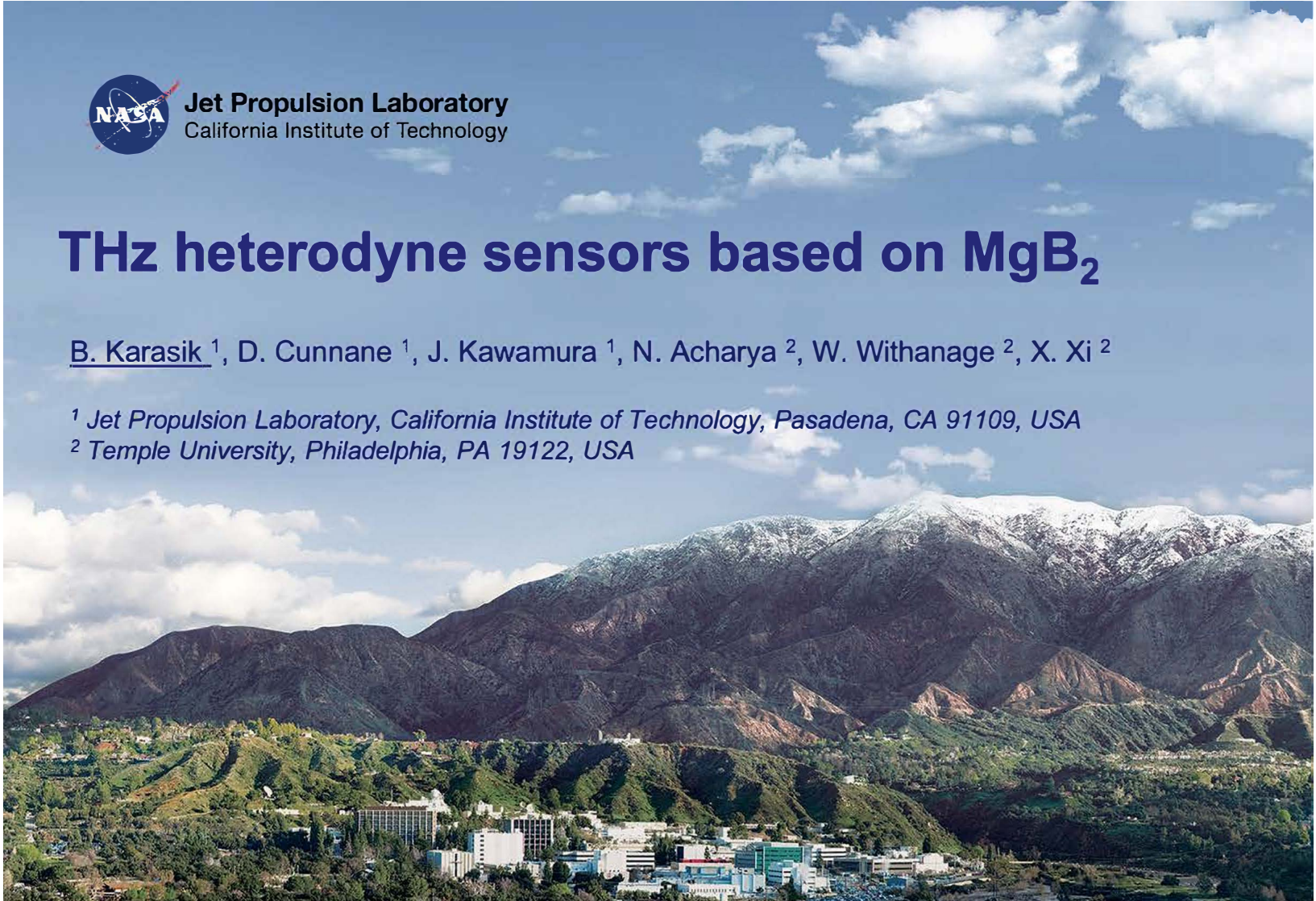
**Jet Propulsion Laboratory**  
California Institute of Technology

# THz heterodyne sensors based on $\text{MgB}_2$

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# The objective

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Advancing the state-of-the-art of THz **hot-electron bolometer (HEB) mixers** for high-resolution molecular line spectroscopy by using  $\text{MgB}_2$  superconducting thin films

- Large IF bandwidth ( $\sim 7$  GHz)
- High operating temperature ( $\approx 15\text{-}20$  K)
- Monolithic array architecture

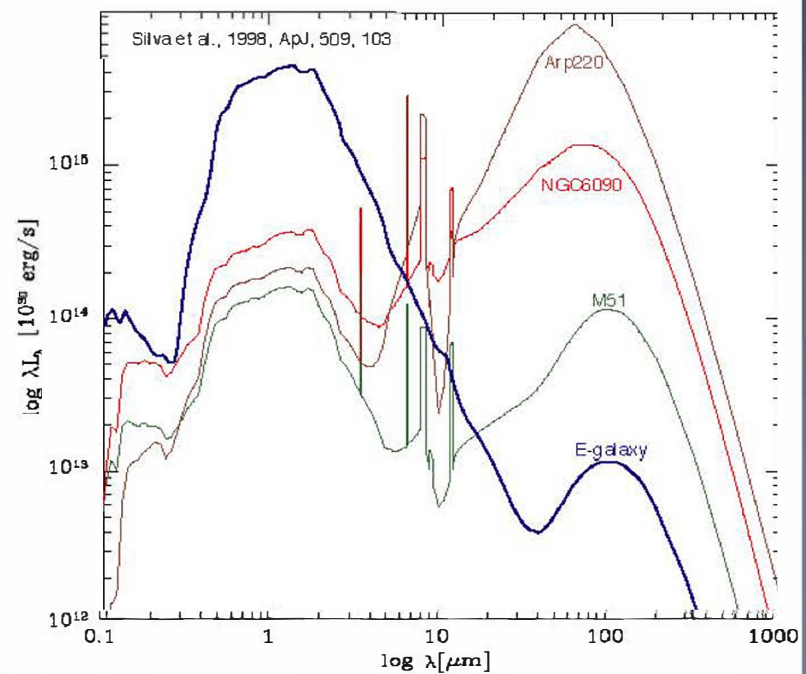
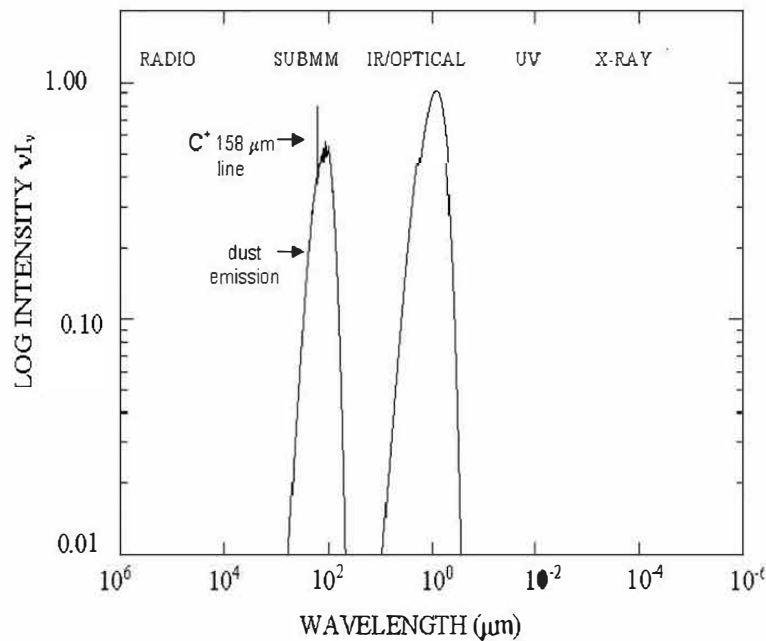
# Outline

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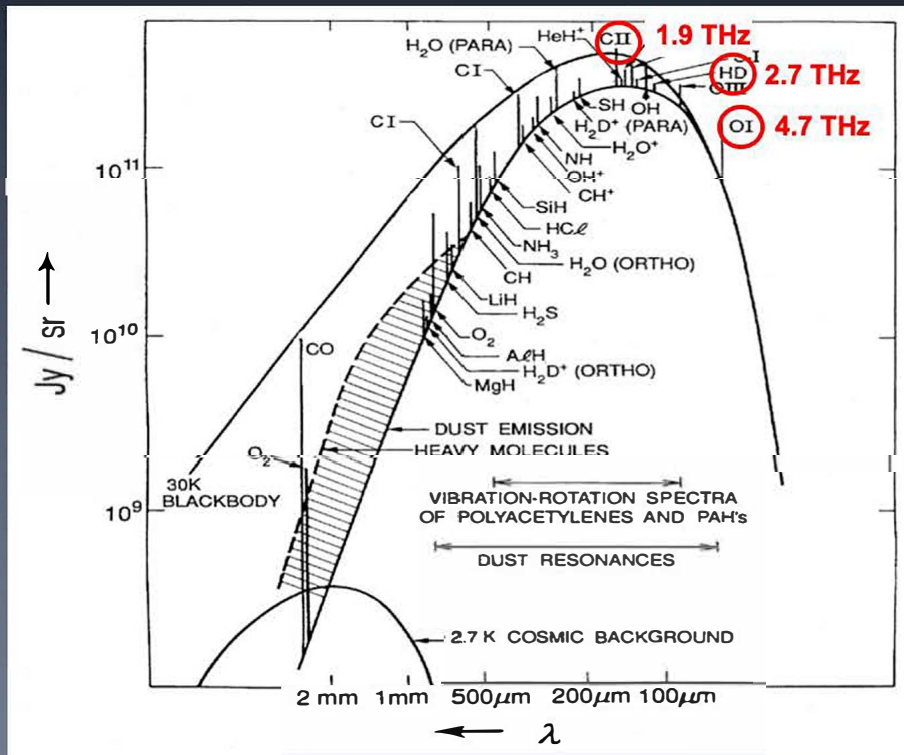
- THz heterodyne spectroscopy in space
- Benefits of the MgB<sub>2</sub> films
- Thin film fabrication
- HEB mixer devices & data
- Josephson junction device & data
- Waveguide based array mixer
- New application: mid-IR broadband mixer
- Summary

# Far-IR galactic emission

- Half the luminosity and 98% of the photons falls into the far-IR region
- Red shifted galaxies from the early universe emit in the of far-IR

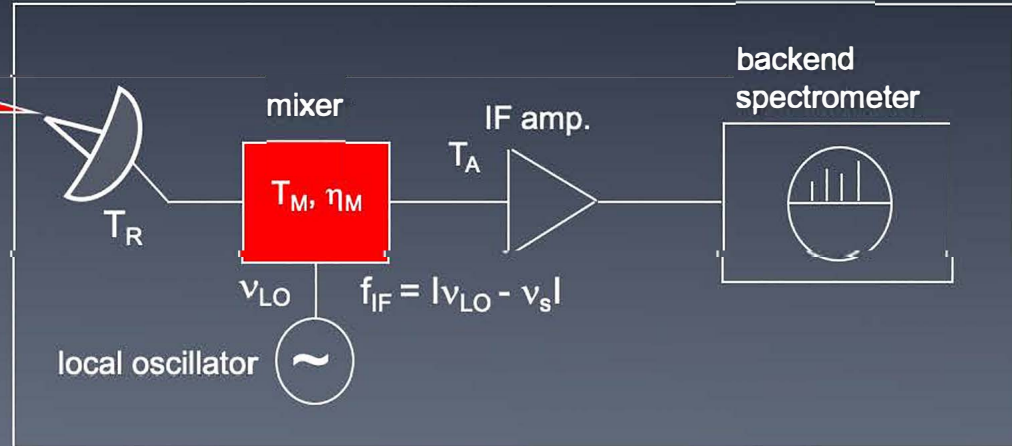
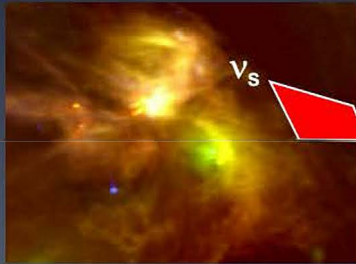


# THz line emission spectrum

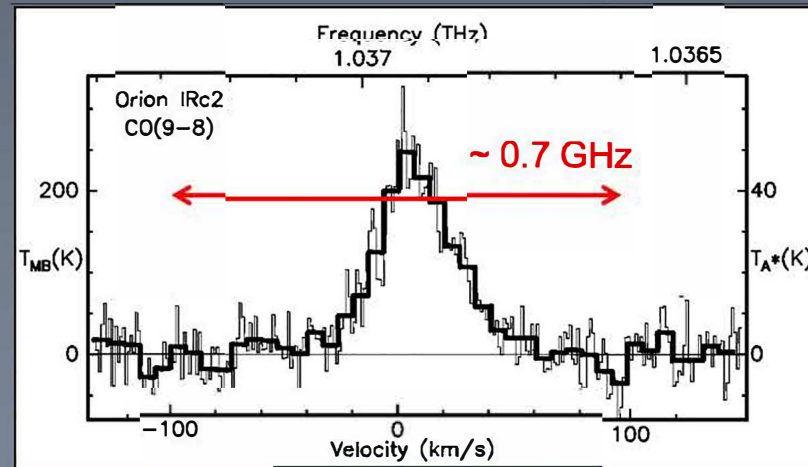
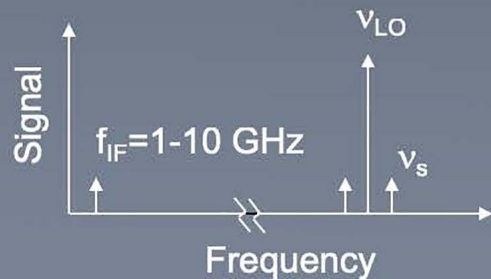


- THz is the primary frequency range for line and continuum radiation from cool (50-100 K) gas (ions, atoms and molecules) and dust
- High resolution ( $\nu/\Delta\nu = 10^6-10^7$ ) spectroscopy provides information about abundance of gas-phase species and their chemistry in regions of star- and galaxy formation

# High resolution heterodyne spectroscopy



- receiver noise:  
 $T_R = T_M + T_A / \eta_M$
- integration time:  
 $\tau_{in} \sim (T_R)^2$



# Herschel Space Observatory (HSO)

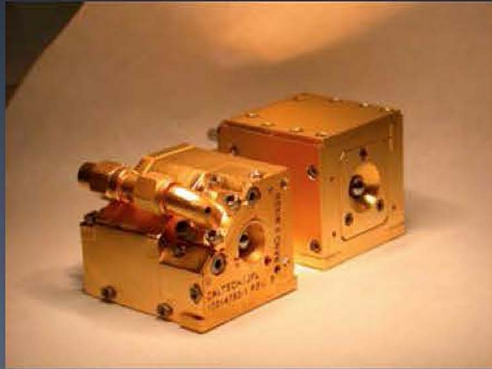
## Heterodyne Instrument for Far-IR (HIFI)



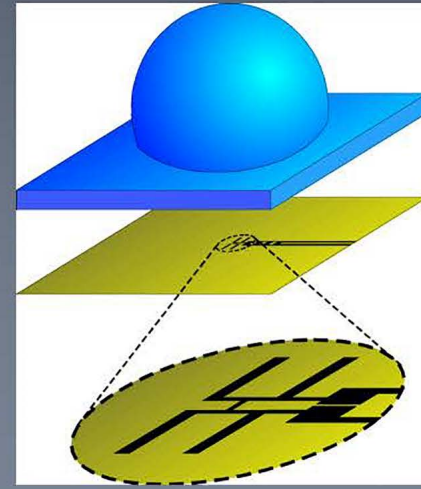
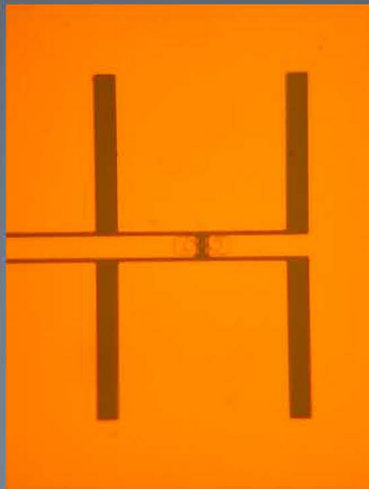
Band	Mixer	LF (GHz)	HF (GHz)
1	SIS	480	640
2	SIS	640	800
3	SIS	800	960
4	SIS	960	1120
5	SIS	1120	1250
6L	HEB	1400	1600
6H	HEB	1600	1910

- Launched on May 14, 2009. Exhausted LHe on April 29, 2013
- HIFI used HEB mixers made from NbN films

# Quasioptical THz HEB mixers

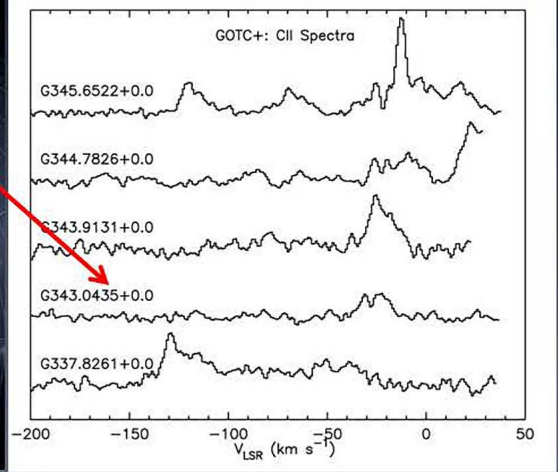
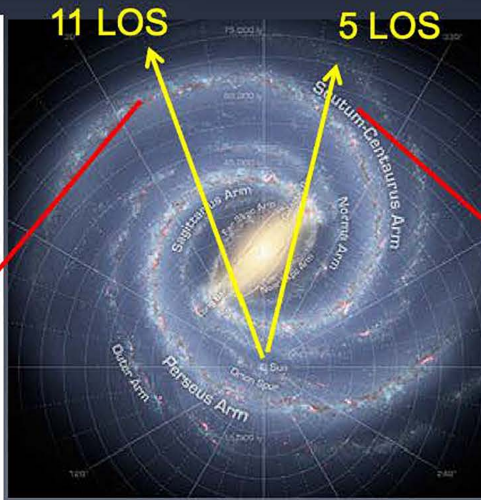
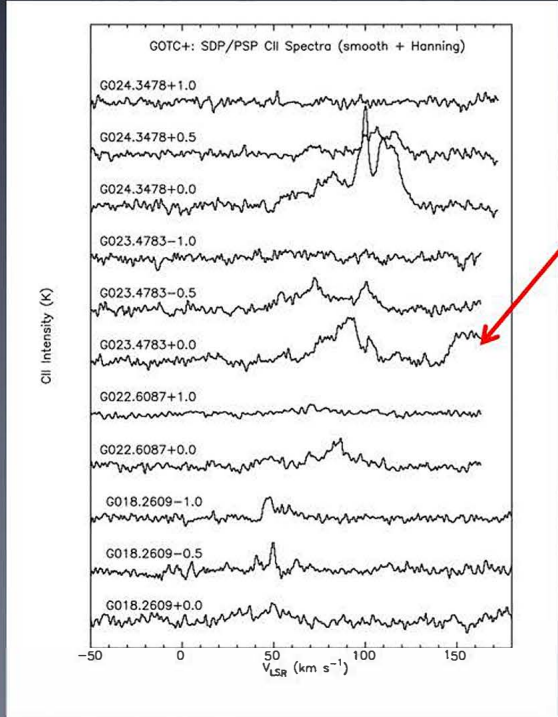


Herschel HIFI Band 5 and 6 mixers



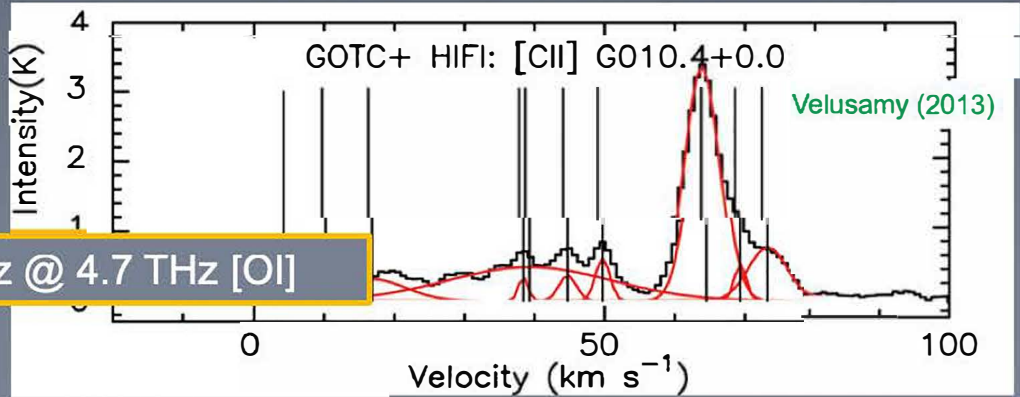


# Galactic observation of THz [CII] line

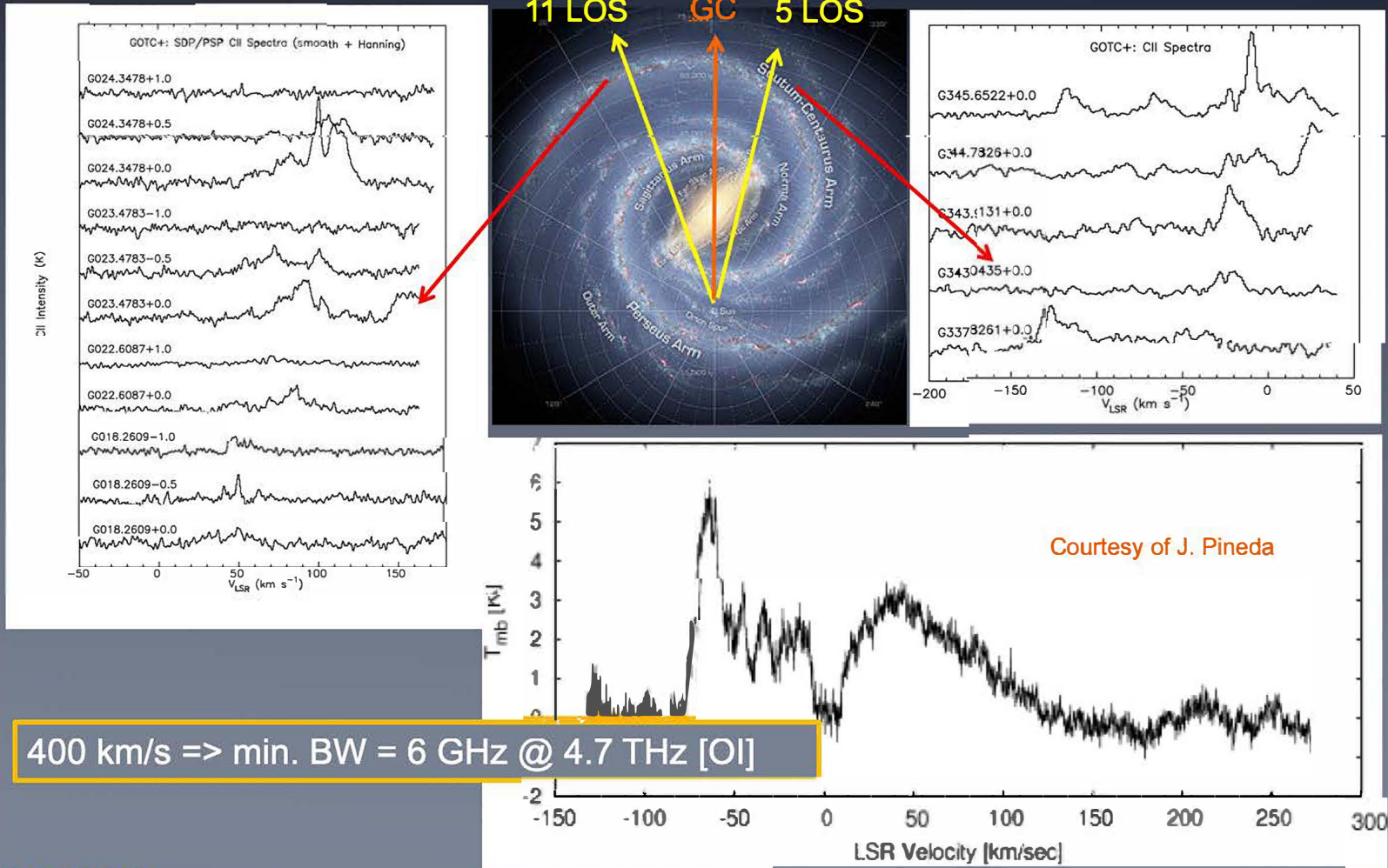


CII from 16 LOS. The yellow arrows indicate the general direction of two sets of observations on either side of the inner Galaxy.

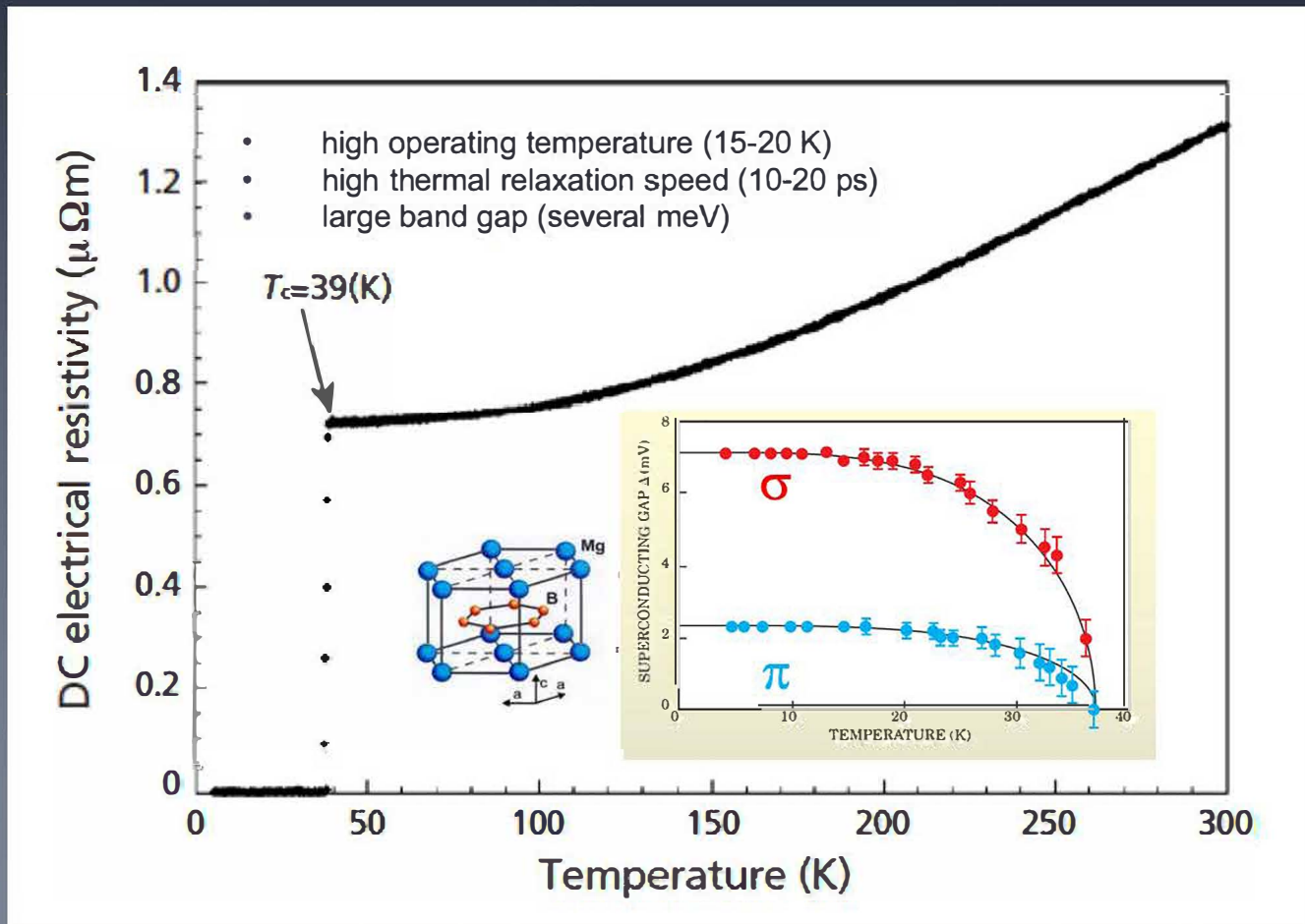
400 km/s => min. BW = 6 GHz @ 4.7 THz [OI]



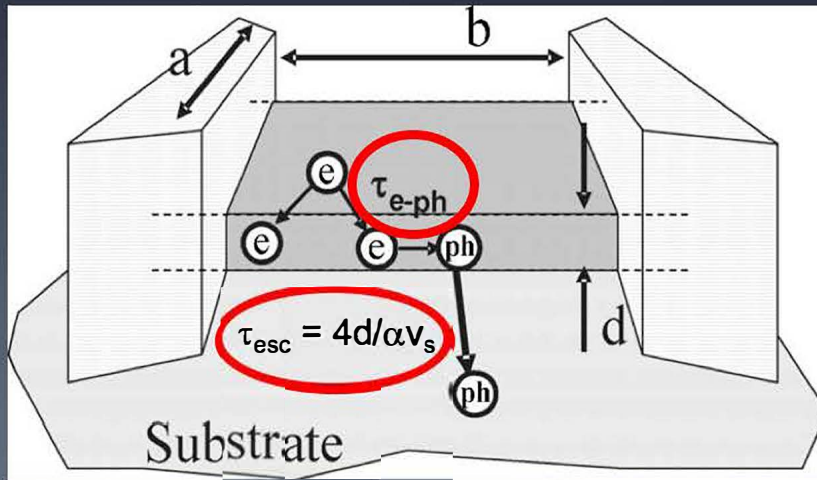
# Galactic observation of THz [CII] line



# MgB<sub>2</sub>

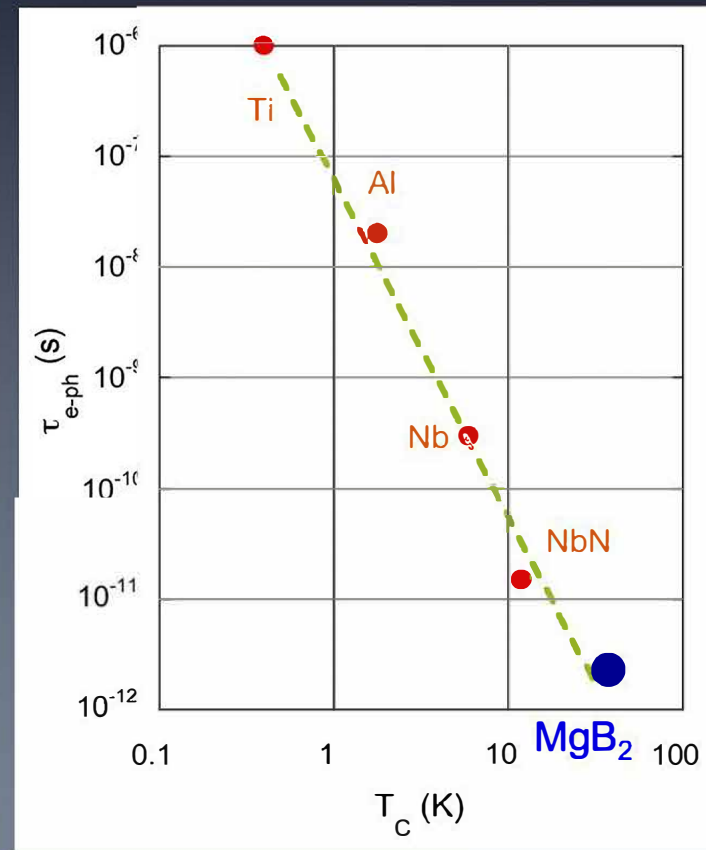


# Electron energy relaxation in thin films

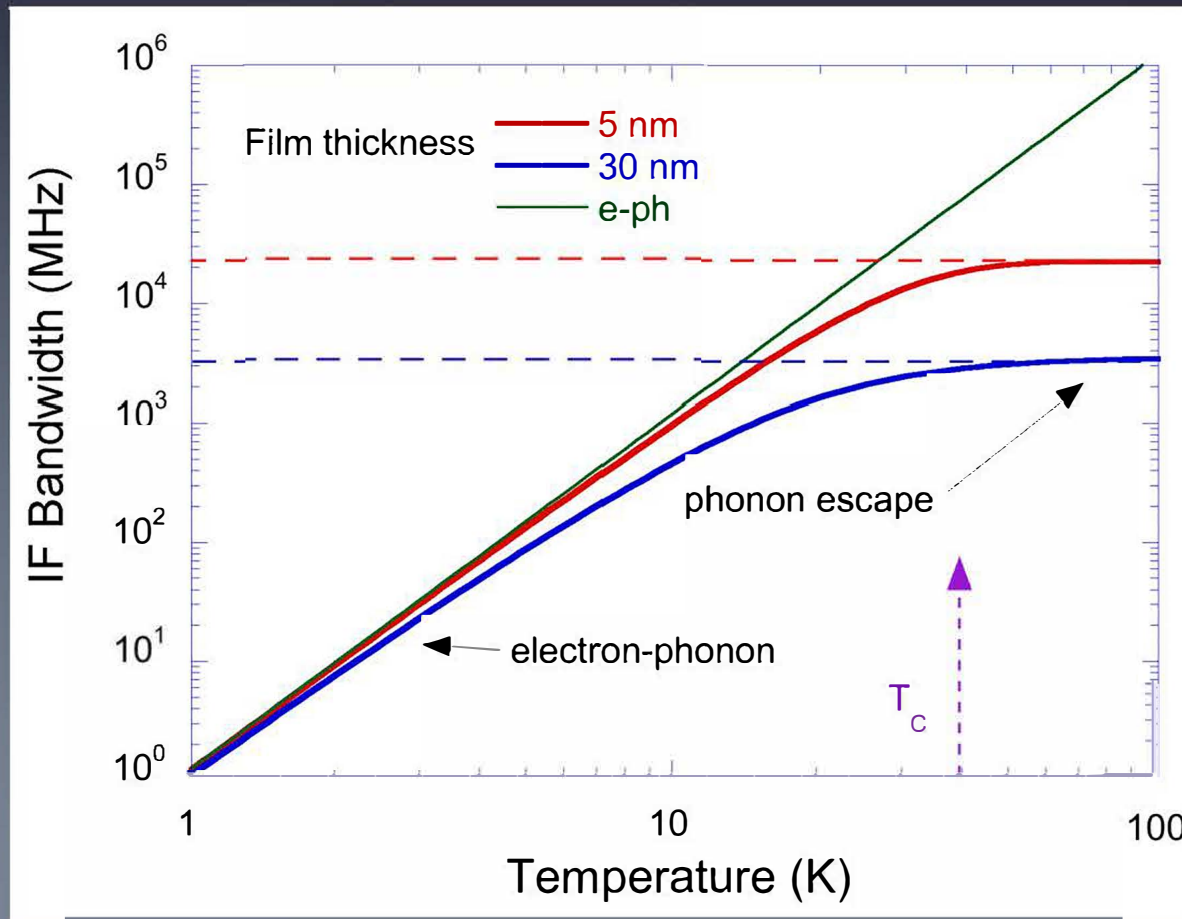


- at  $T > 4K$ , phonons partially escape film but partially return energy to electrons
- very thin films and good acoustic transparency at the film-substrate interface are needed to accelerate the phonon escape

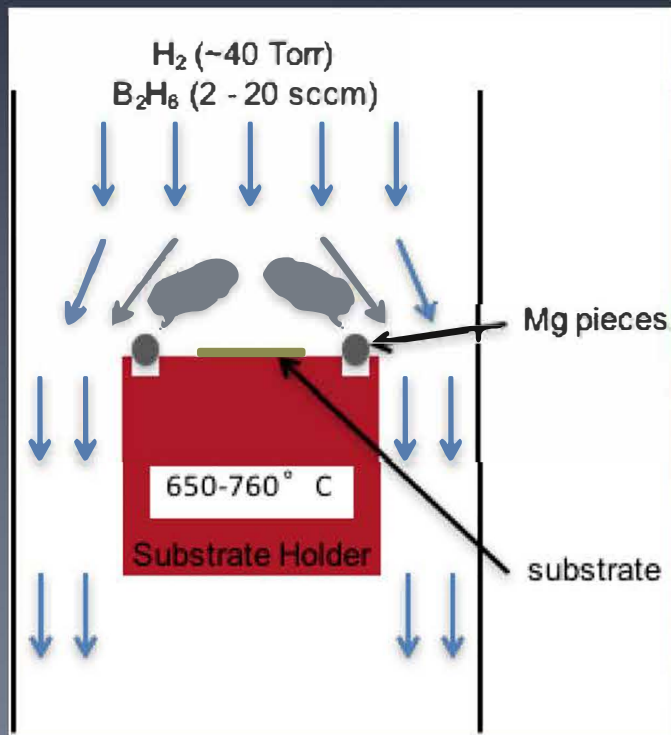
Material	$MgB_2$	$NbN$
$v_s$ (km/s)	7.8	2.5



# Electron energy relaxation in MgB<sub>2</sub> film



# Hybrid Physical-Chemical Vapor Deposition (HPCVD)



- c-axis oriented films on 6H-SiC
- thinnest films ( $\leq 10$  nm) with high  $T_c$  and moderate resistivity ( $\sim 10^5 \mu\Omega$  cm)

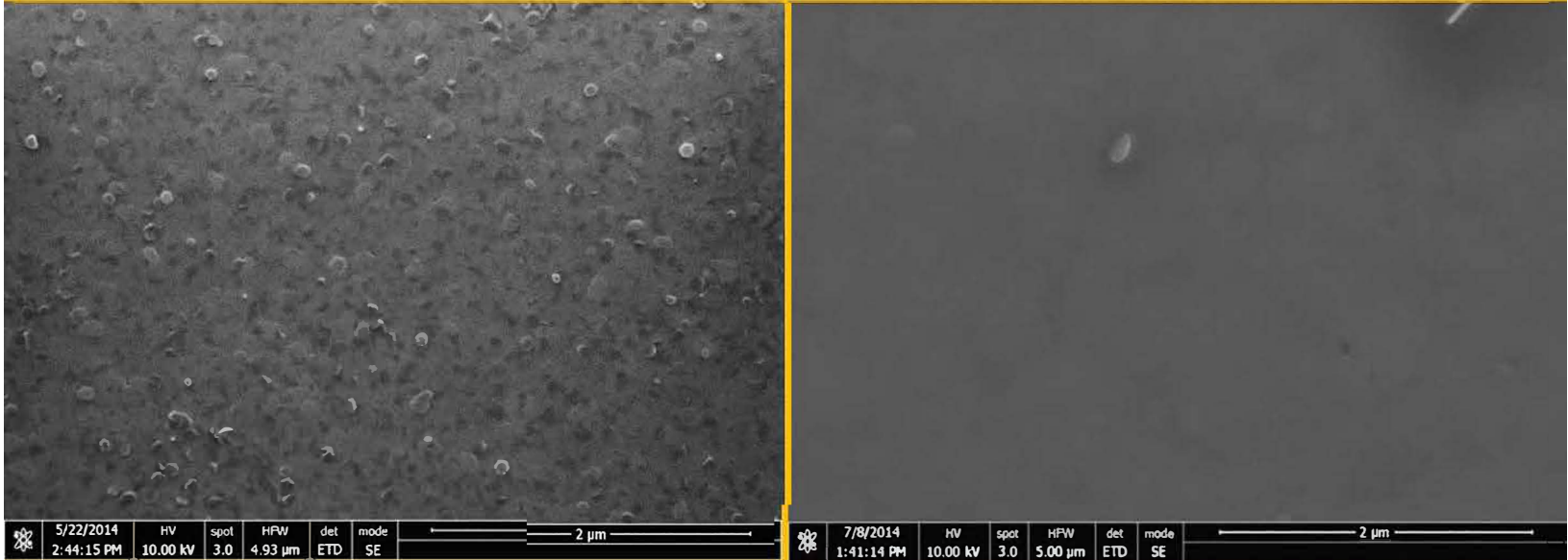
## Fast escape of phonons from MgB<sub>2</sub> to SiC

phonon escape ( $\tau_{es} = 4d/v_s\alpha$ ) is the bottleneck for the energy relaxation in MgB<sub>2</sub> HEB

Material	MgB <sub>2</sub>	NbN
$v_s$ (km/s)	8-10	2.5



# As-grown and ion milled 15 nm thick films

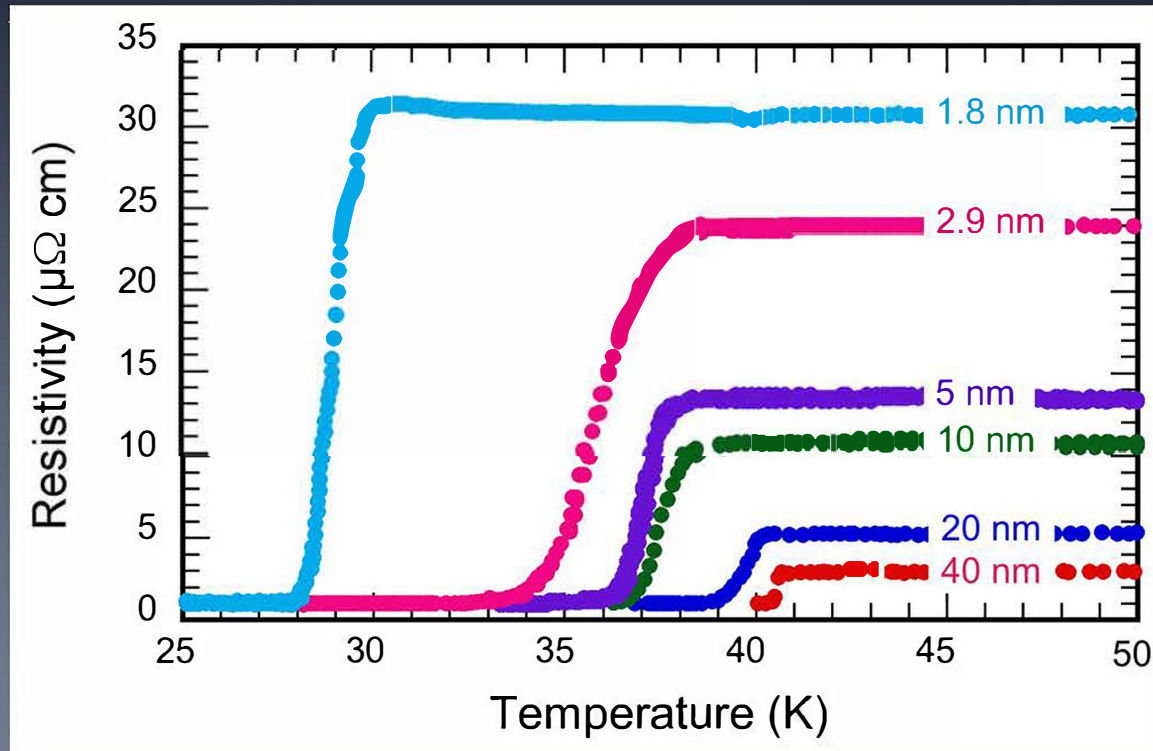


HPCVD alone

HPCVD+ion mill



## Ion-milled thin films with high $T_C$



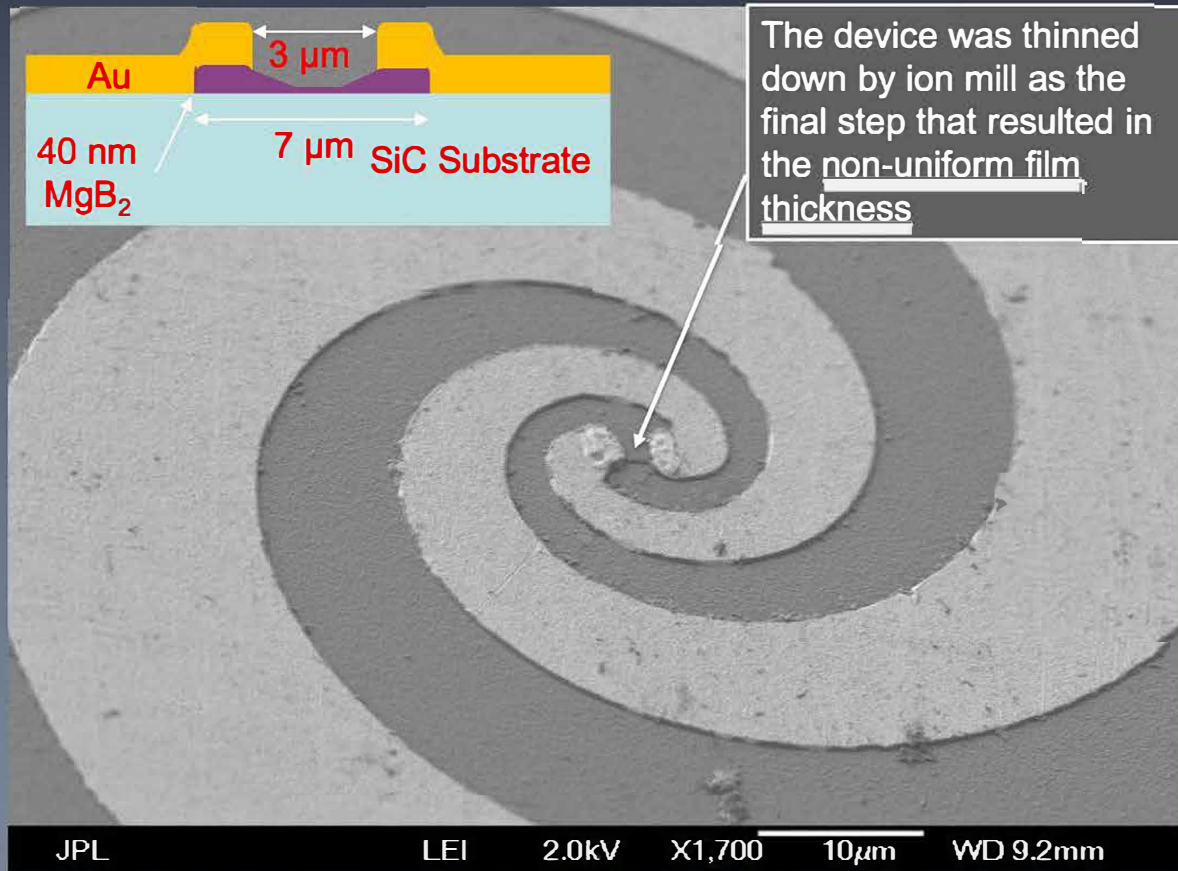
- very thin as-grown films ( $< 10$  nm) lose continuity
- ultrathin films were achieved using ion mill of thicker ( $\sim 40$  nm) continuous films
- Good quality superconducting material ( $j_C \sim 10^7$  A/cm $^2$ )

N. Acharya et al., *APL Mater.* 4, 086114 (2016)

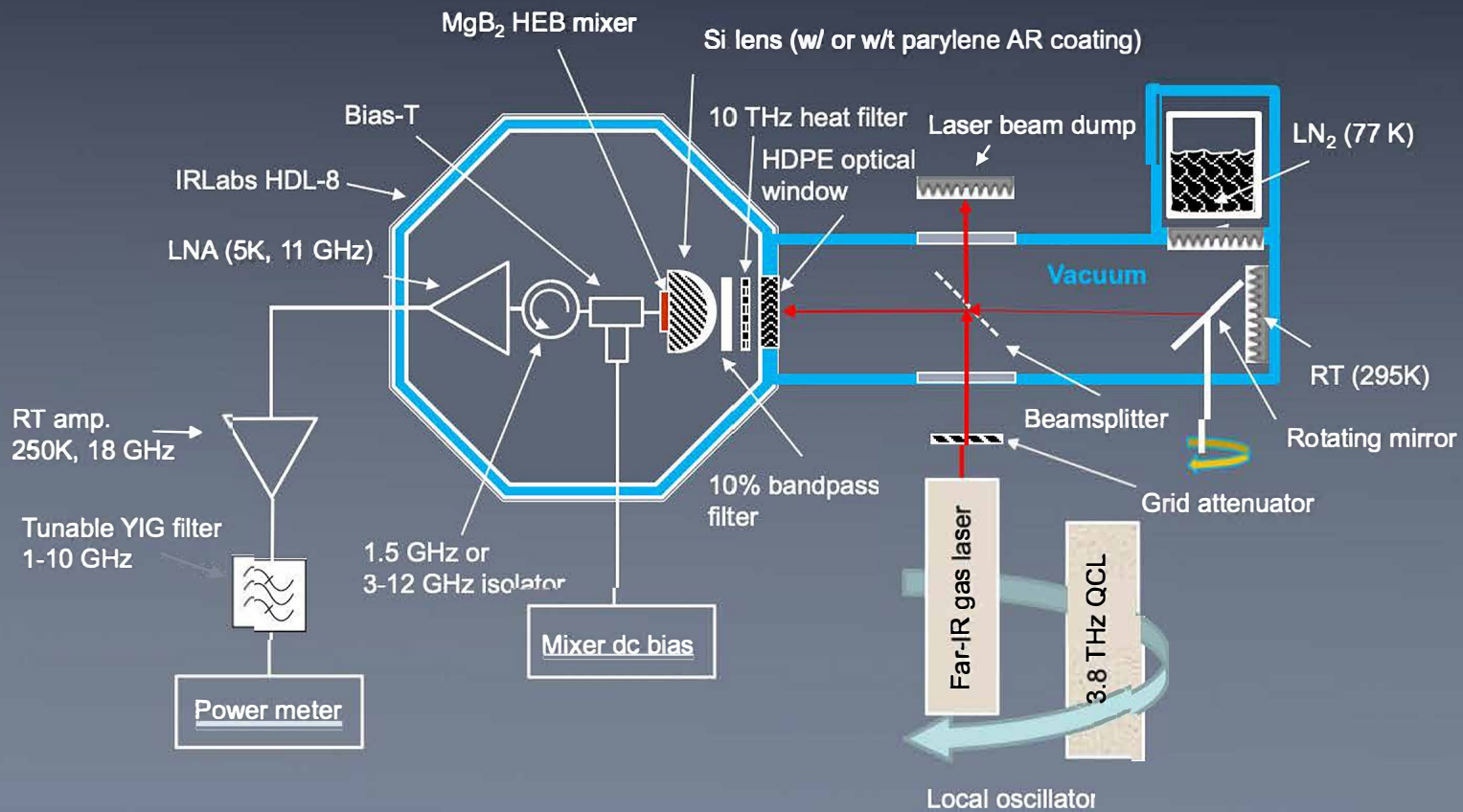
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# Antenna-coupled HEB devices

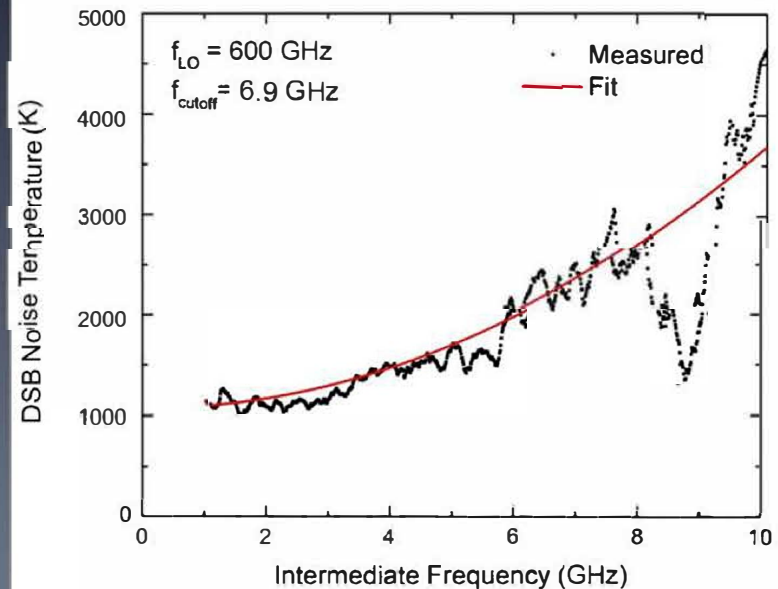
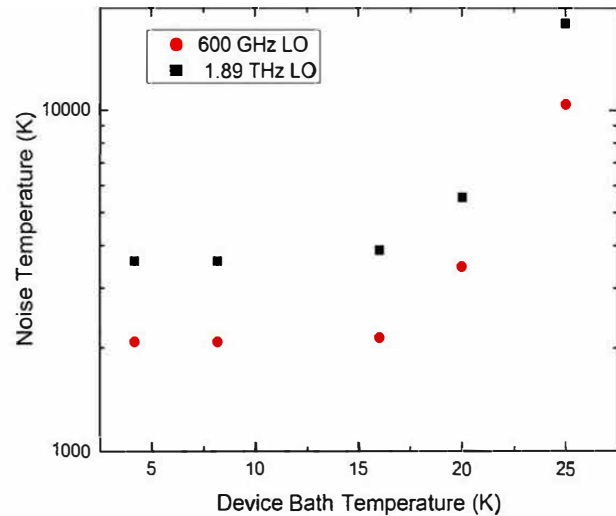
Prior to the device fabrication, films are *ex-situ* passivated with SiO<sub>2</sub> or Au



# THz test setup



# Noise temperature and bandwidth

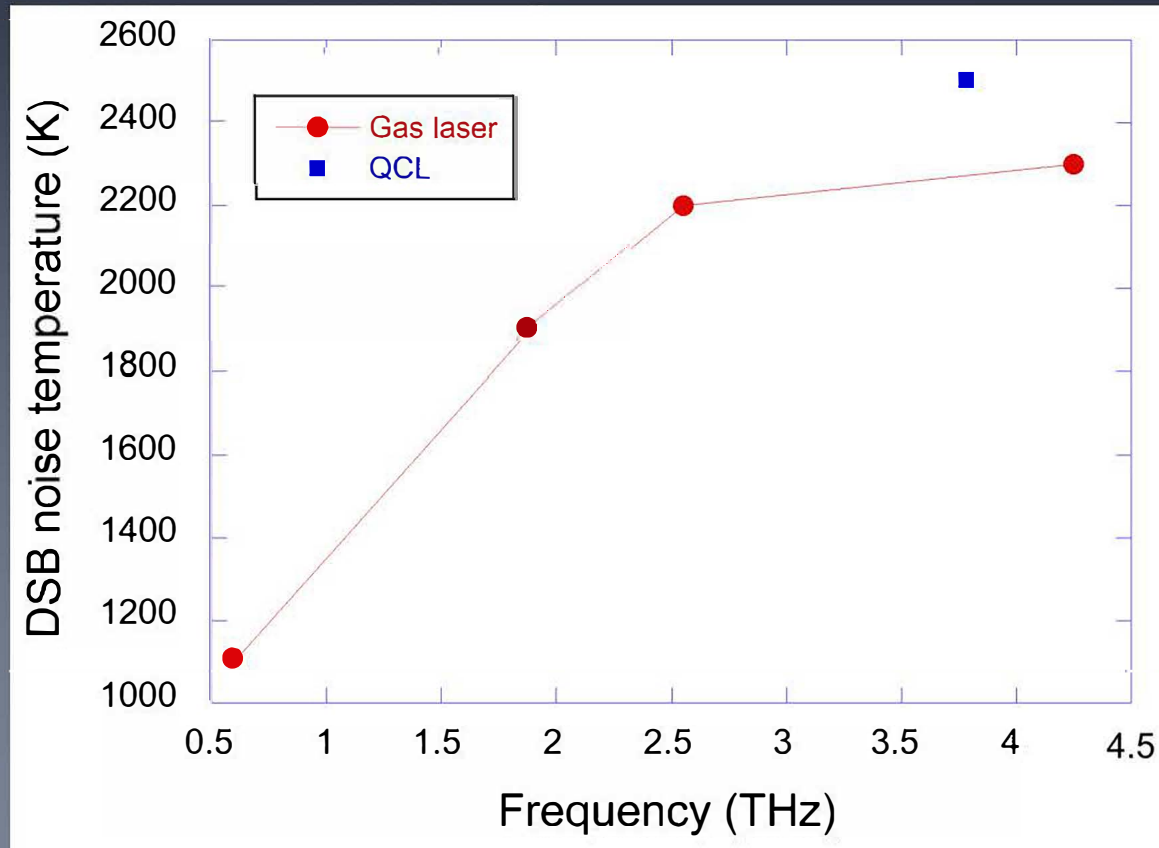


- No noise temperature degradation up to at least 15 K. Acceptable increase at 20 K.
- A 6.9 GHz noise bandwidth.

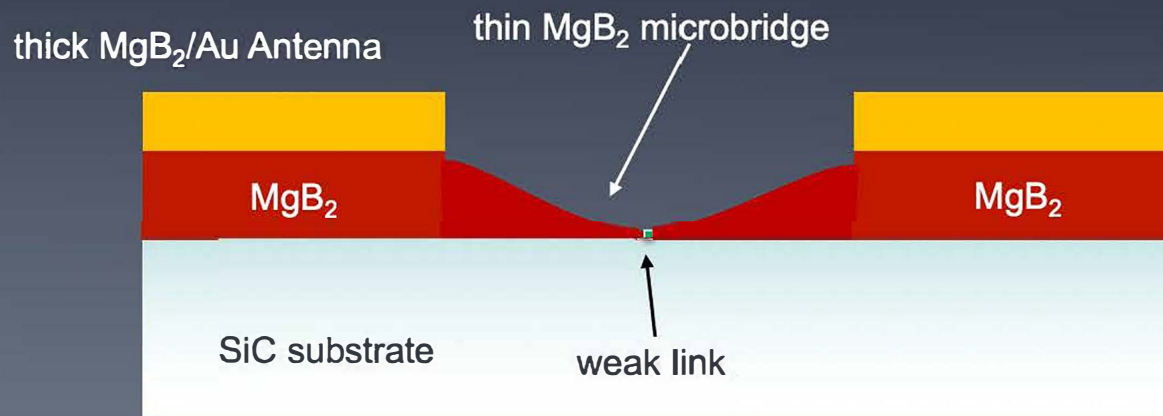
D. Cunnane et al., *IEEE TAS* 27, 2300304 (2017)

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## Summary of the noise temperature data

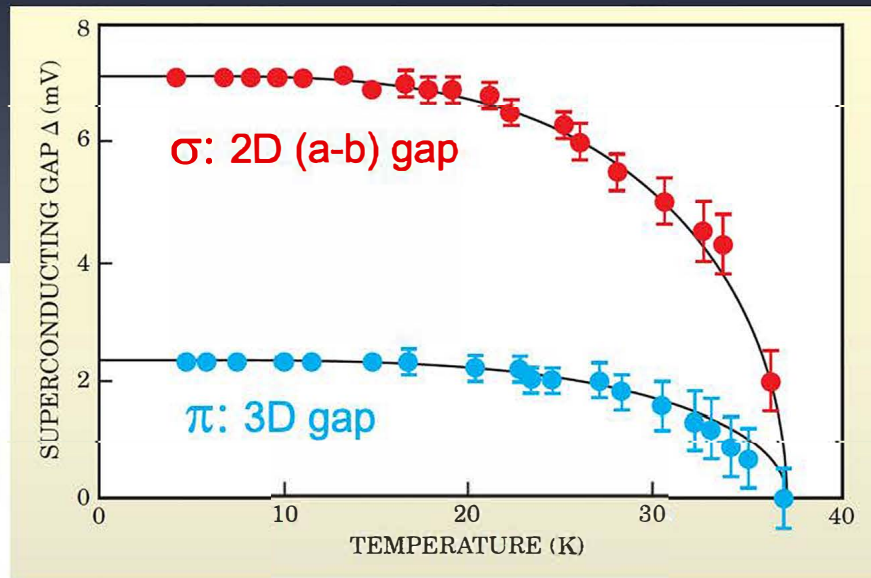
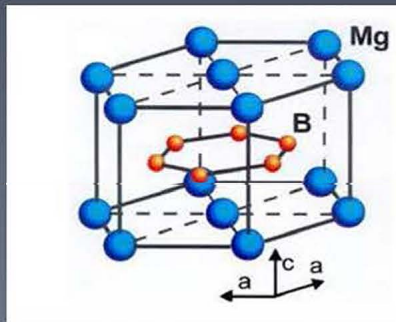


# In-plane Josephson junction



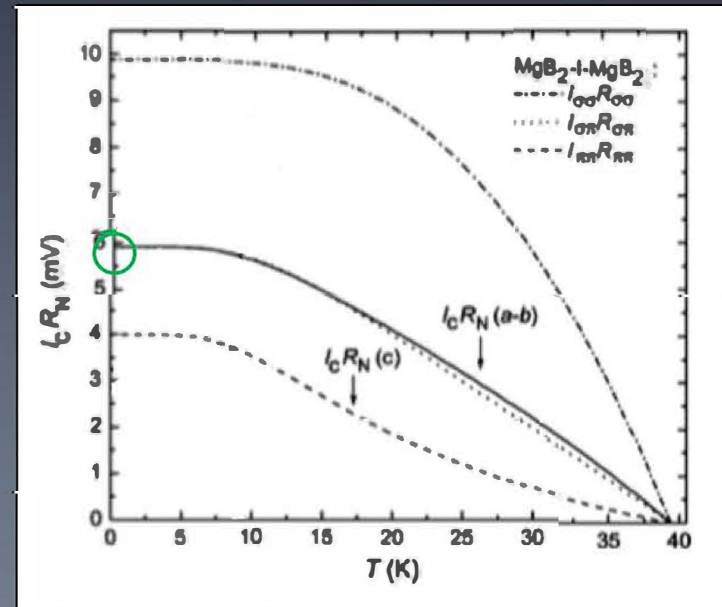
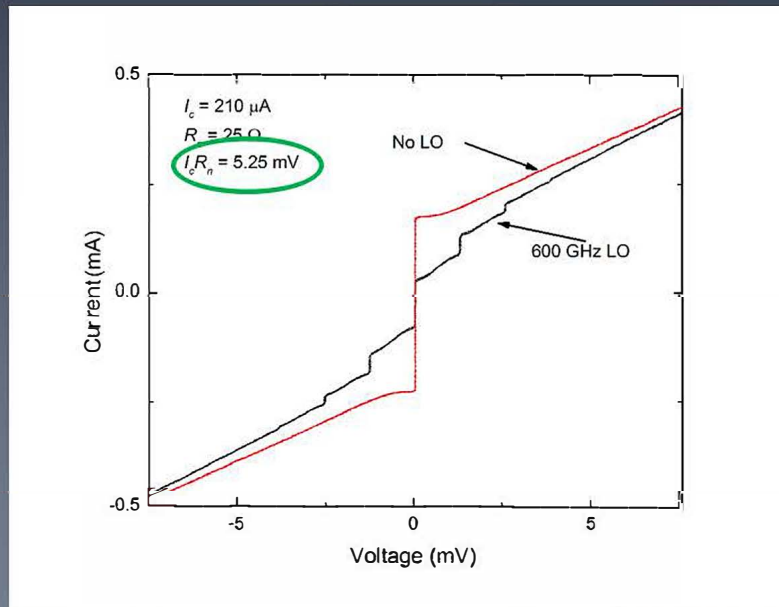
- in-plane (a-b) WL junction is due to the overetch of the film during the ion mill process
- similar technique using Focused Ion Beam (FIB) was employed for fabrication of YBCO JJ  
[Cybart et al., NatNANO 10, 598 \(2015\)](#)
- because of the strong c-axis orientation of the film,  $\sigma$ -gap contributes in Josephson tunneling

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# Josephson mixing at 600 GHz

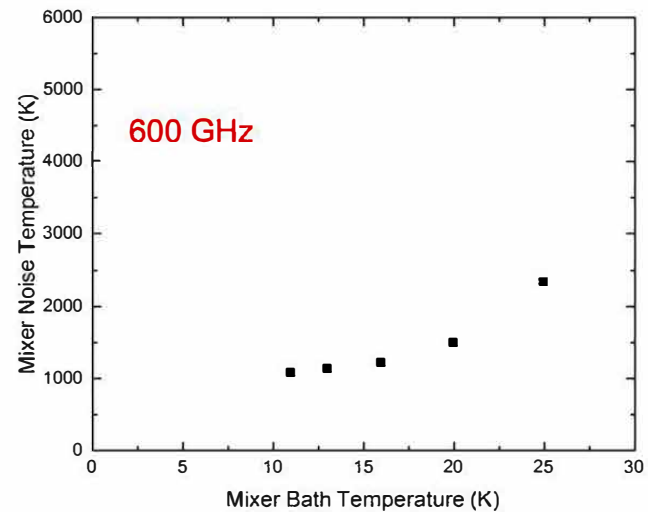
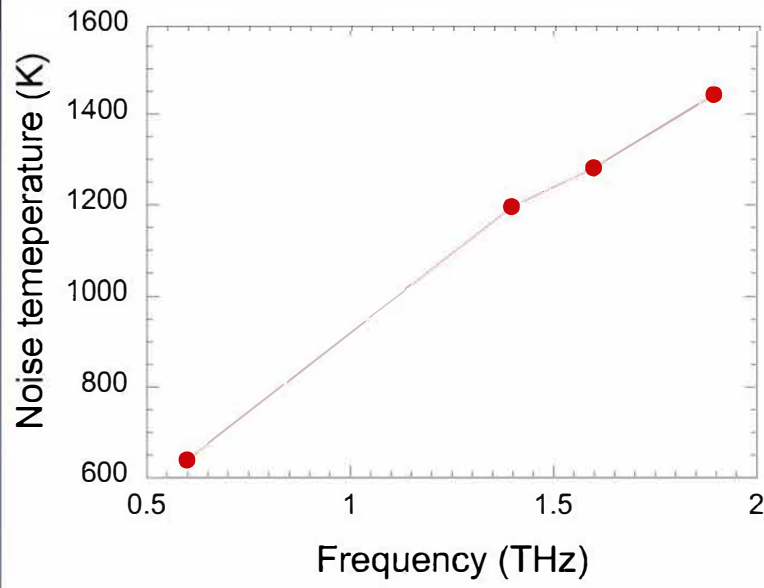


D. Cunnane et al., *Appl. Phys. Lett.* **109**, 112602 (2016) A. Brinkman et al., *Phys. Rev. B* **65**, 180517R (2002)

Shapiro steps at  $V = hv/2e$

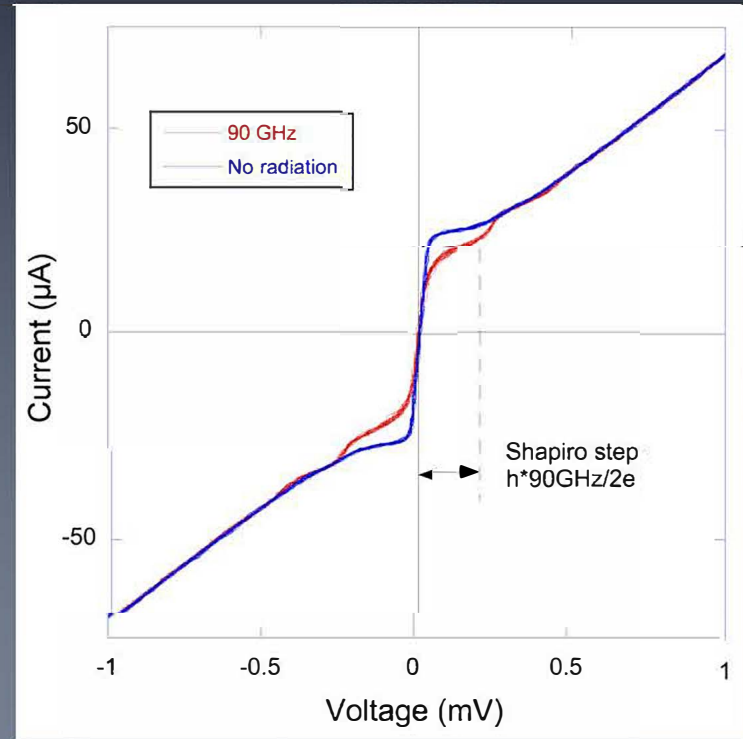
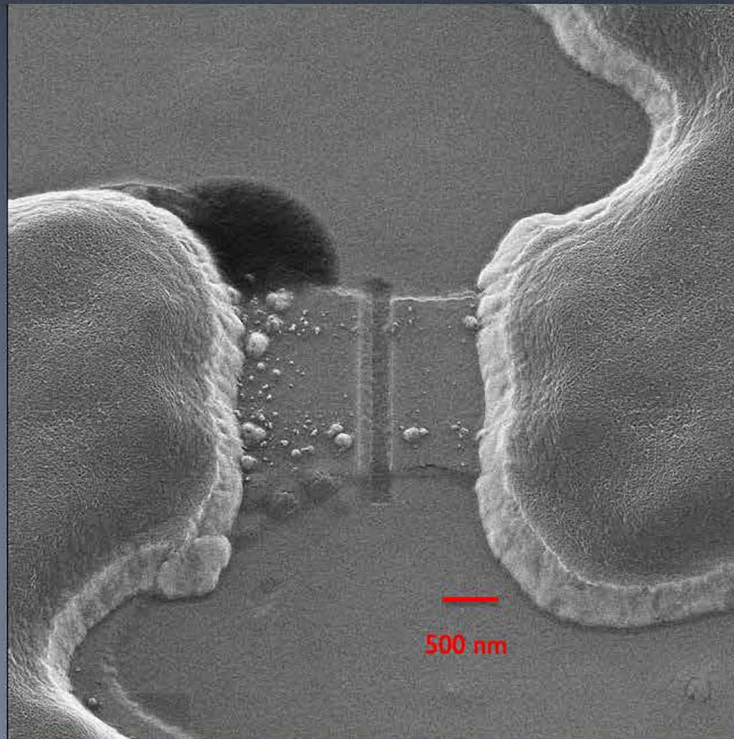


# JJ mixer noise temperature

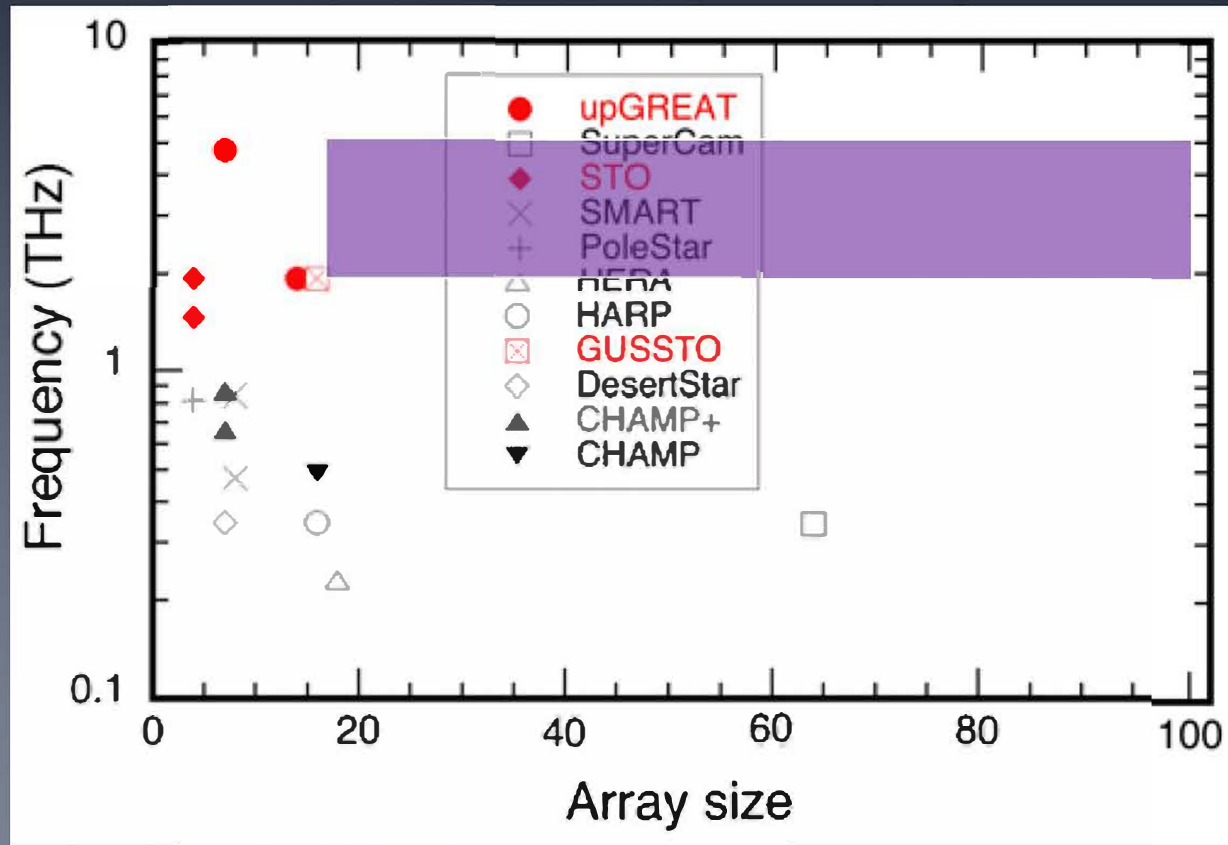


- NT  $\approx$  1,500 K has been measured at 1.9 THz
- focused development of this technology will likely improve NT

# In-plane JJ using FIB technique

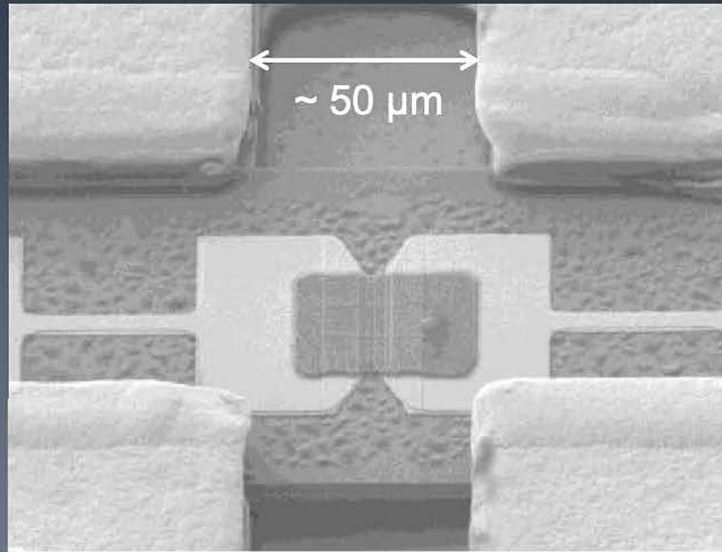


# THz heterodyne arrays



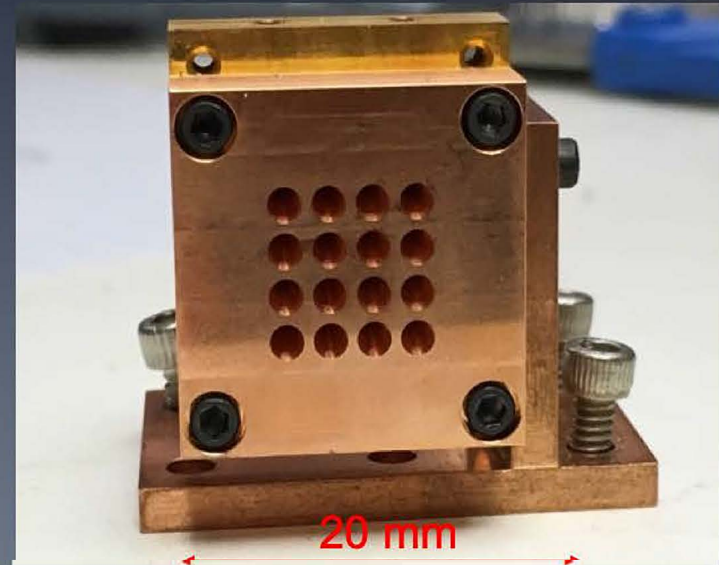
# Waveguide THz HEB mixers

## 2.7 THz / JPL



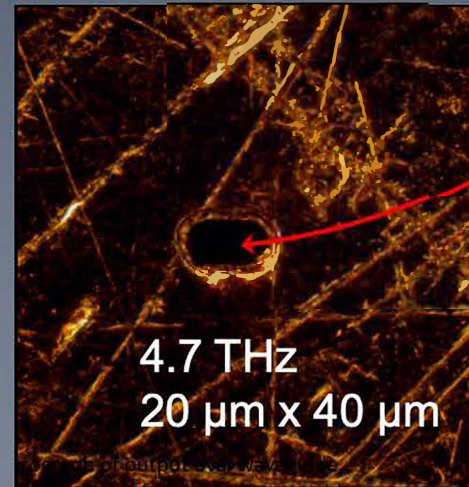
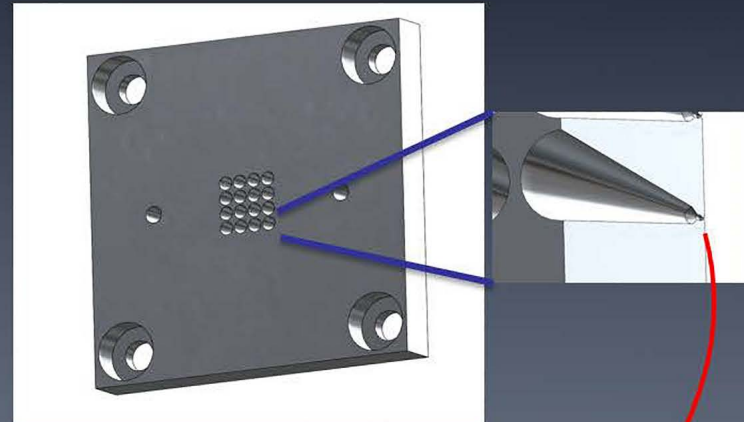
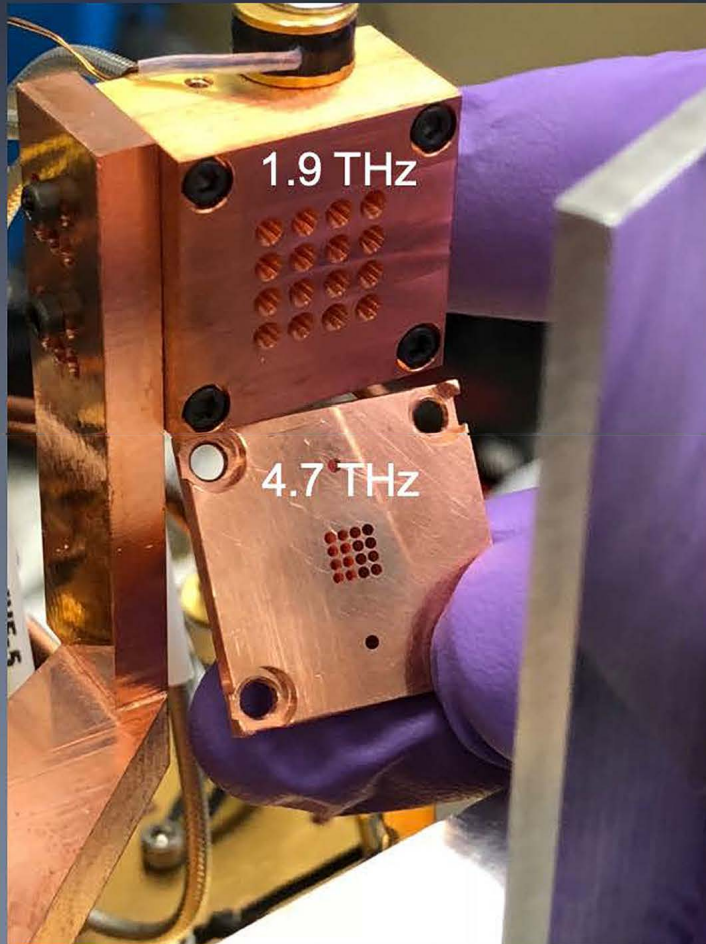
2.7 THz fixed-tuned HEB NbN mixer in a single-mode waveguide block. The mixer circuit is suspended with a  $\sim 2.3 \mu\text{m}$  thick Si substrate

F. Boussaha et al., *IEEE Trans. TST.* 2, 284 (2012)

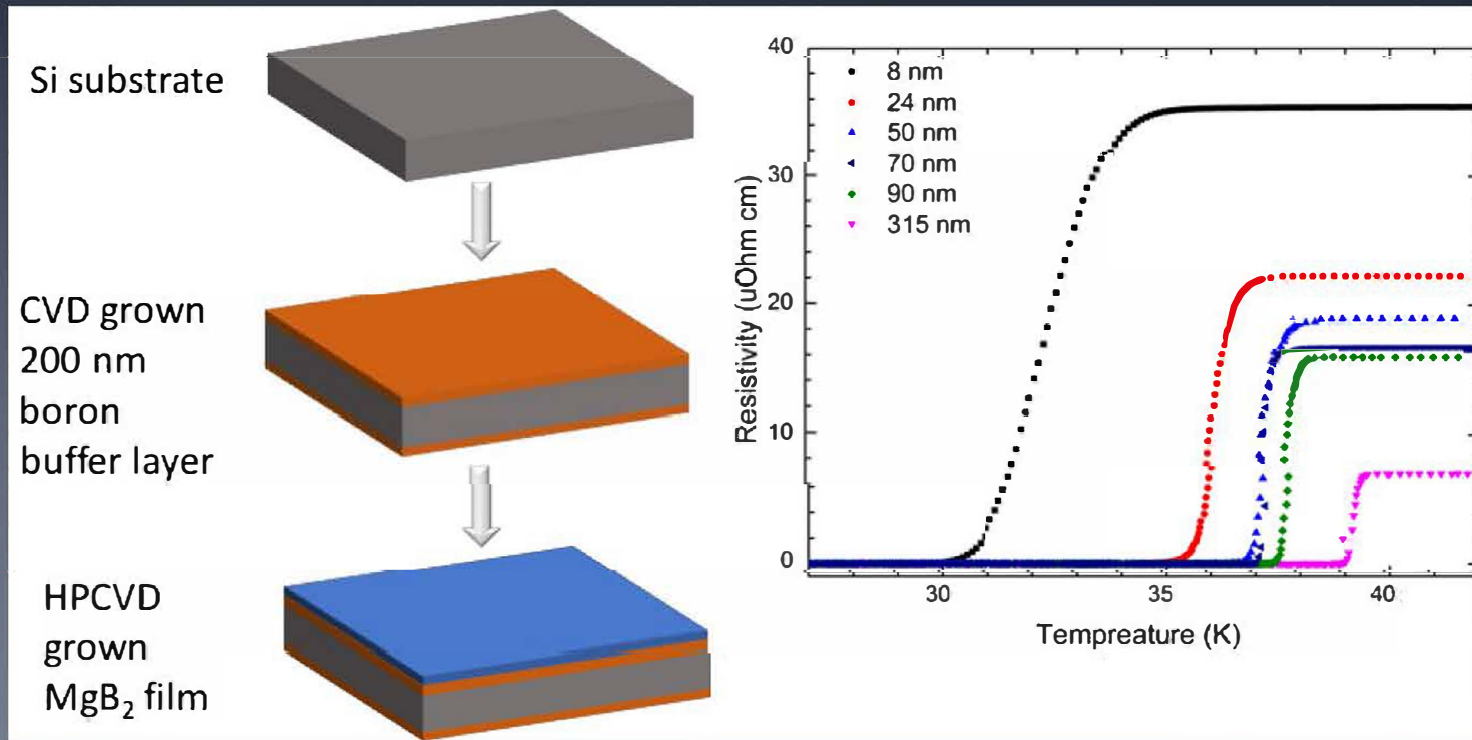


The JPL prototype 2 THz mixer has 16-pixels in a monolithic package with no practical limit to the number of pixels (the goal is 100 pixels)

# 16-pixel horn-antenna block



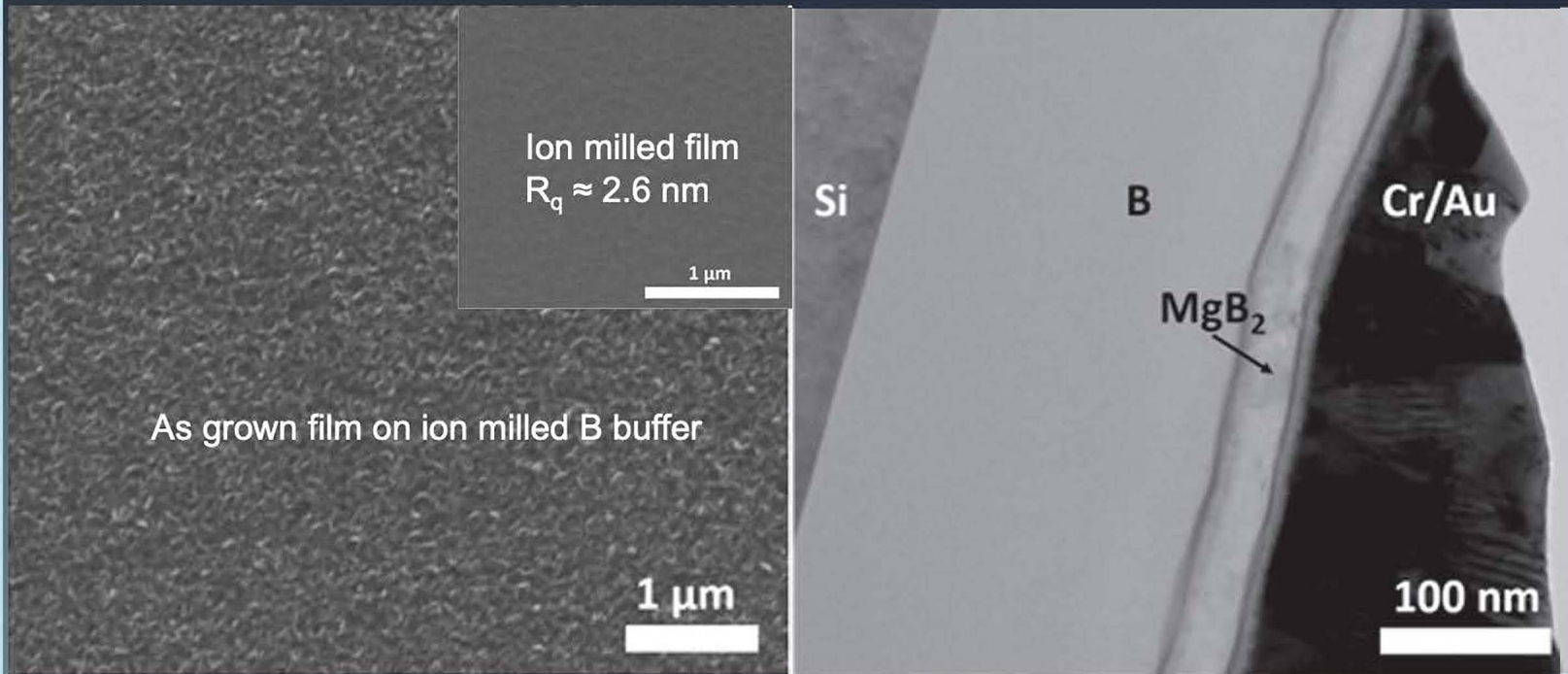
# MgB<sub>2</sub> on Si



- Boron buffer layer protects Si against reaction with Mg at 700 C
- MgB<sub>2</sub> film on SOI wafer fabricated

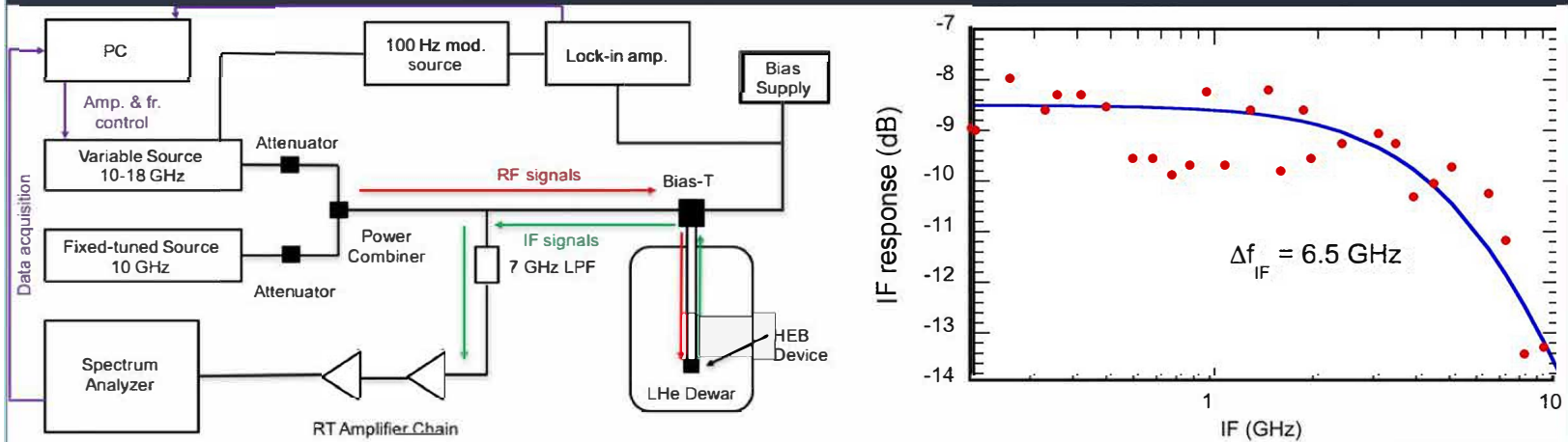
W. Withanage et al., *SuST* 31, 075009 (2018)

# MgB<sub>2</sub> film on Si



- Superconducting properties similar to those in films grown on SiC
- Clean interface between the film and the buffer

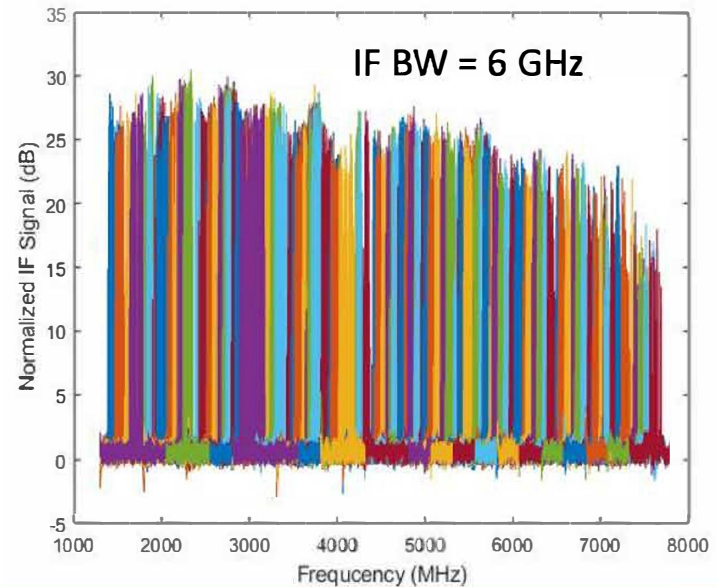
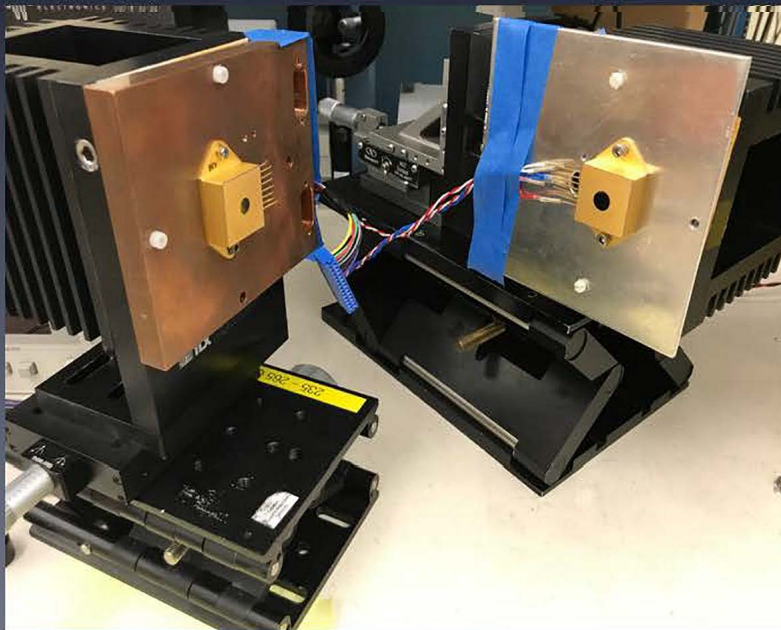
# IF bandwidth in MgB<sub>2</sub> HEB on SOI



- Measurements of the bandwidth using two low-power microwave sources
- The device is biased just below TC to ensure a temperature sensitive, continuous IV characteristic
- The IF bandwidth figure is similar to that for SiC substrate



# 10- $\mu\text{m}$ mixing using $\text{MgB}_2$ HEB



- SOA mid-IR heterodyne detectors (e.g., HgCdTe photo-diode) have a typical IF bandwidth  $\sim$  1 GHz
- Applications in frequency-comb spectrometers, interferometers, and lidars require detectors with larger bandwidth, up to 10 GHz
- The IF bandwidth in HEB is a thermal property and does not depend on the radiation frequency
- Given the high power LO available at 10  $\mu\text{m}$ , one can use large HEB devices cavity-coupled to radiation

# Summary

- Ultrathin MgB<sub>2</sub> films (HPCVD deposition + ion mill) are available for THz detector development
- QO HEB mixers made from these films demonstrate good noise performance up to 20 K throughout the entire THz range
- A noise bandwidth of about 7 GHz has been achieved in HEB mixers
- J mixer, is a promising approach to the mixers at 1.9 THz requiring low LO power (needed for arrays)
- Ultrathin MgB<sub>2</sub> films on Si have been developed for achieving the waveguide based array mixer
- There is a potential for expansion of MgB<sub>2</sub> HEB mixers into the mid-IR range where large IF bandwidth is required for a number of applications



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